FIG.1

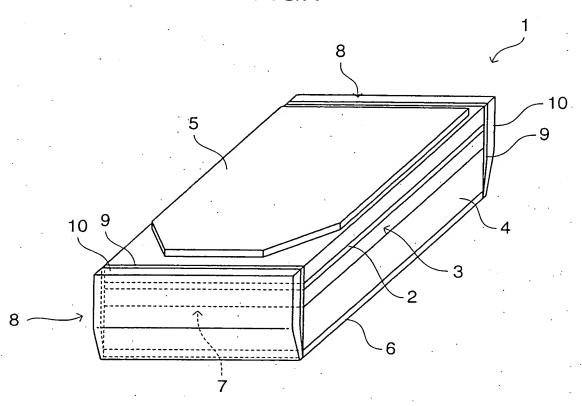


FIG.2

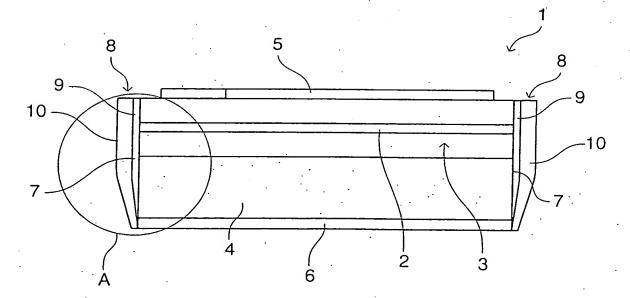


FIG.3

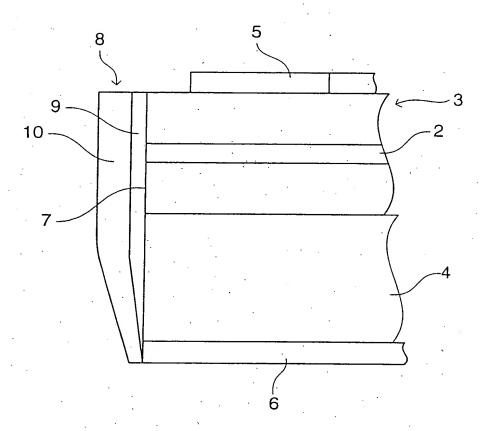


FIG.4(a)



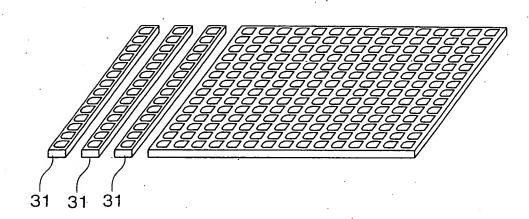


FIG.4(b)

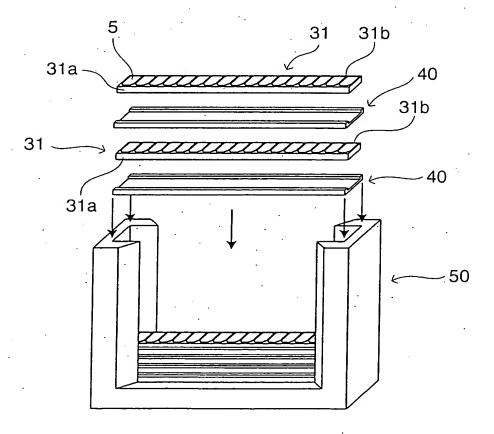


FIG.5(c)

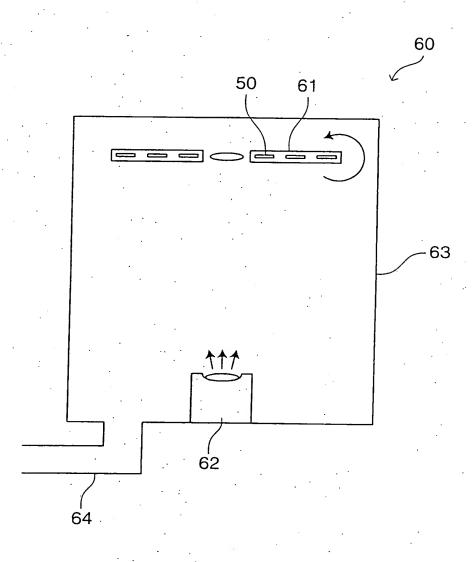


FIG.6(a)

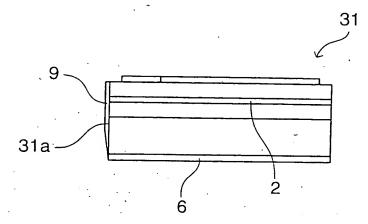


FIG.6(b)

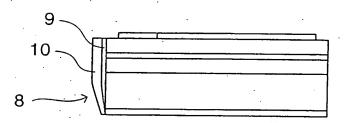


FIG.6(c)

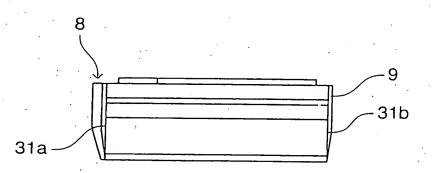


FIG.6(d)

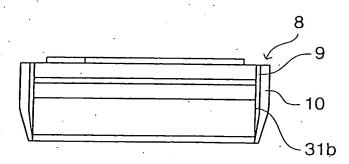


FIG.7(e)

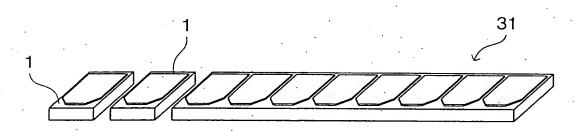


FIG.8

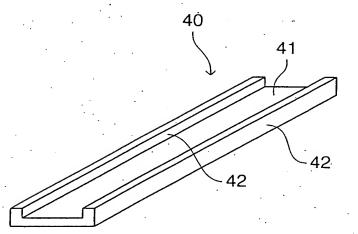


FIG.9

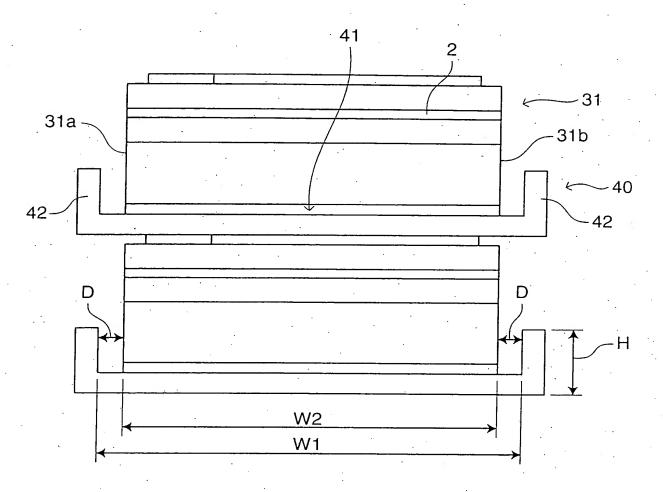
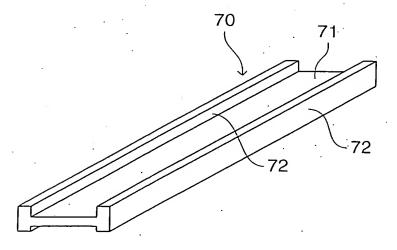


FIG.10



App No.: Not Yet Assigned Inventor: Noboru OSHIMA

Docket No.: 259052004000

Title: SEMICONDUCTOR LASER DEVICE, PRODUCTION METHOD THEREFOR, AND JIG FOR USE IN THE

PRODUCTION METHOD

FIG.11

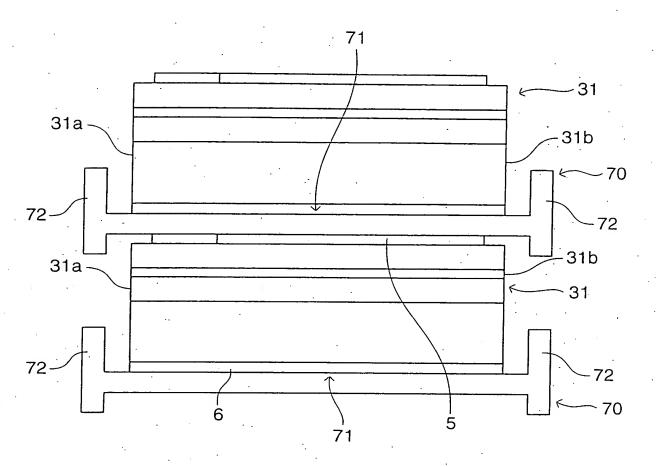
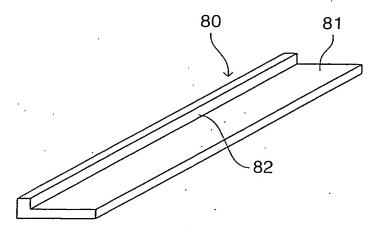


FIG.12



App No.: Not Yet Assigned Inventor: Noboru OSHIMA

Docket No.: 259052004000

Title: SEMICONDUCTOR LASER DEVICE, PRODUCTION METHOD THEREFOR, AND JIG FOR USE IN THE

PRODUCTION METHOD

FIG.13

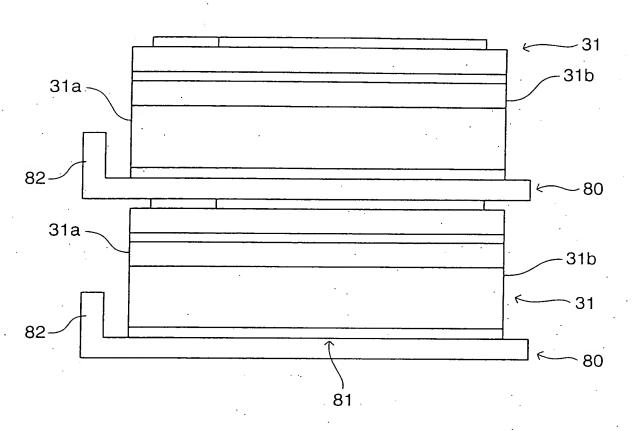


FIG.14

